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## INFORMATION DISCLOSURE STATEMENT BY APPLICANT

Complete if Known Application Number (Natl. phase of PCT/JP04/16386) Filing Date (Herewith) First Named Inventor Yuiirou ISHIKAWA (Unassigned) Art Unit Examiner Name (Unassigned)

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(Use as many sheets as necessary) of 1 Sheet 1

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Examiner Signature	/Ka Chun Leung/	Date Considered	08/01/2008

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